



U.S. Department of Commerce Patent & Trademark Office INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Attorney Docket No. 010986.52578US	Serial No. 10/615,926
	Applicant: YAMASAKI et al.	
	Filing Date July 10, 2003	Group 2878

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
	AA						
	AB						
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	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Sub- Class	TRANSLATION	
							Yes	No
AK		2001-234348	08/31/2001	Japan			AB	
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

AQ	SATAKE, T., "Gas Phase Analysis of MOCVD Materials by FTIR" Horiba Technical Reports, No. 22, March 2001, pp. 36
AR	
AS	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.